



Docket No. 8733.1014.00
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Oh-Nam KWON

Application No. 10/786,038

Filed: February 26, 2004

For: MANUFACTURING METHOD OF ELECTRO
LINE FOR SEMICONDUCTOR DEVICE

Customer No. 30827

Confirmation No. 2919

Art Unit: 2818

Examiner: David Yu

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL OFFICE ACTION

Sir:

In response to the final Office Action dated December 26, 2006, please amend the patent application identified above as follows:

INTRODUCTORY COMMENTS

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 5 of this paper.

Do not Enter

DV

04/05/07